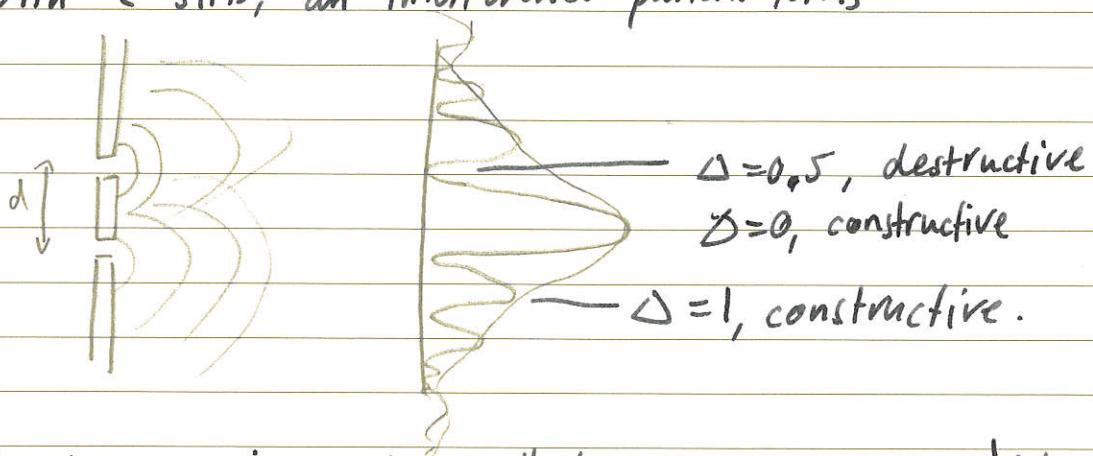


# C. Diffraction

No. VO  
Date 20.11.18

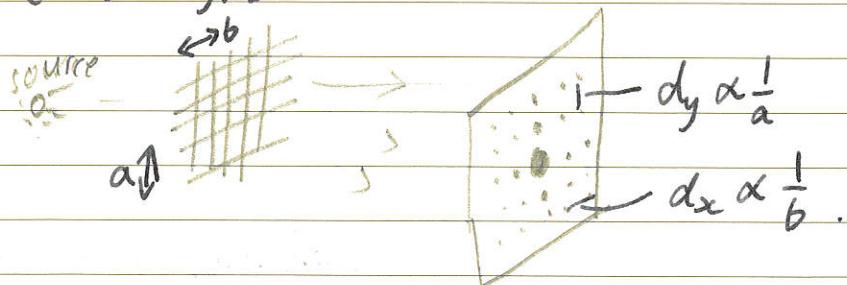
## Optical Diffraction

- Diffraction through a slit can be analysed with the Huygens-Fresnel principle, in which a wave can be described as an infinite line of sources.
- With 2 slits, an interference pattern forms

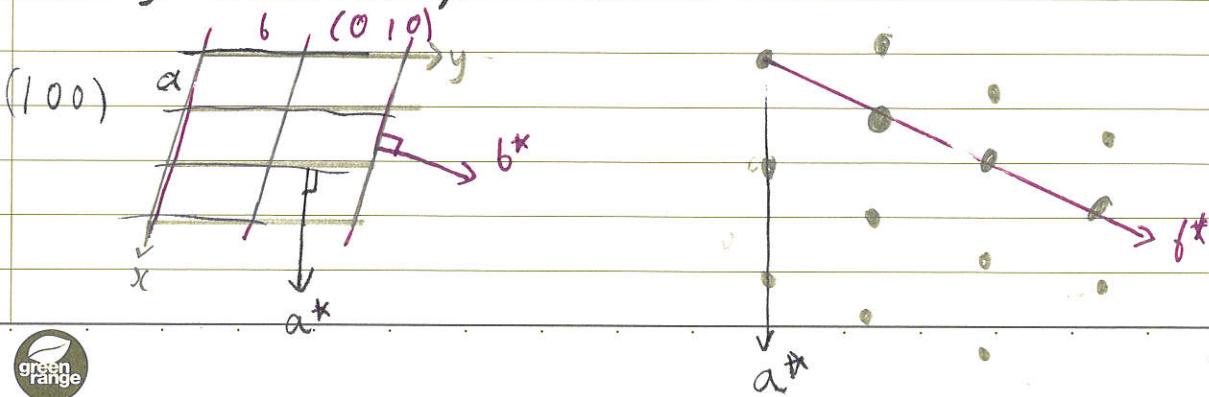


- Young's experiment found that peak spacing  $\propto \sqrt{d}$ .
- For many slits, the maxima become sharp, tending toward  $\delta$  functions.  
↳ i.e. destructive interference everywhere except  $\Delta = n\pi$ .

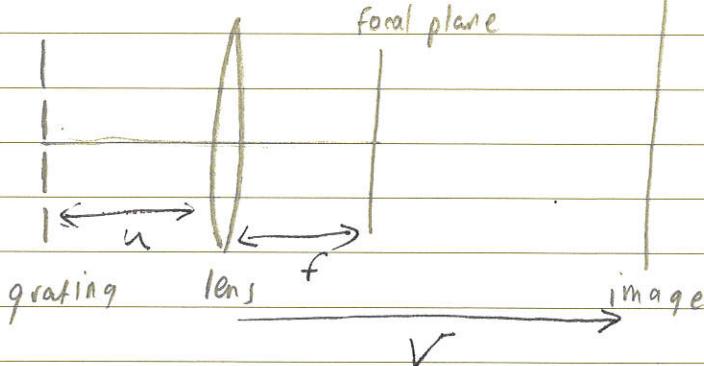
- A 2D diffraction grating behaves like two 1D gratings at cross angles



- Diffraction is always perpendicular to the set of slits  
e.g. for non-orthogonal axes.



## Optical microscopes and resolution

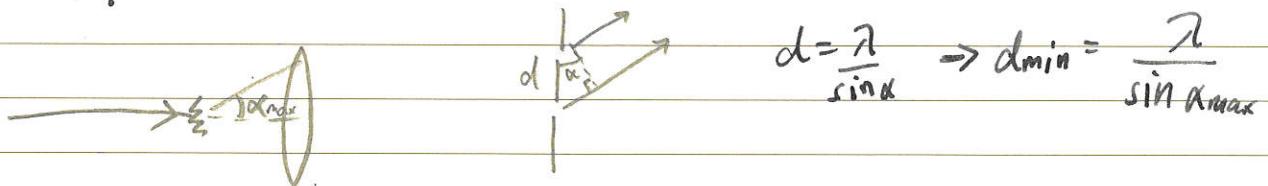


Focal length equation:

$$\frac{1}{f} = \frac{1}{u} + \frac{1}{v}$$

$$\text{Magnification} = \frac{v}{u}$$

- Abbe's Theorem states that resolving a grating with separation  $d$  requires two beams (direct and first order) to enter the lens.

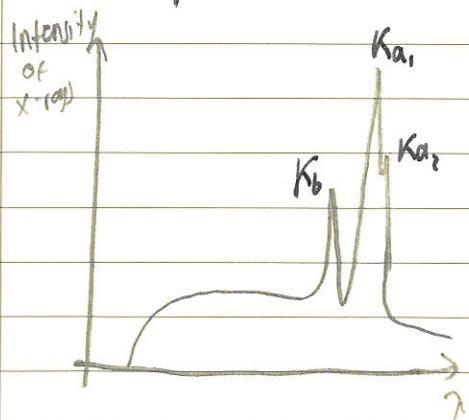


- Resolution can actually be improved by a factor of 2 because light is scattered above and below:

$$d_{min} = \frac{\lambda}{2 \sin \alpha_{max}}$$

## X-ray Diffraction

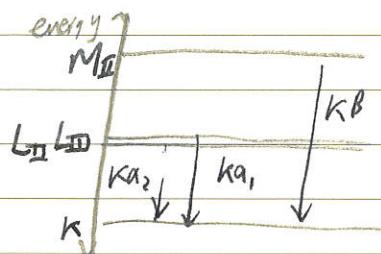
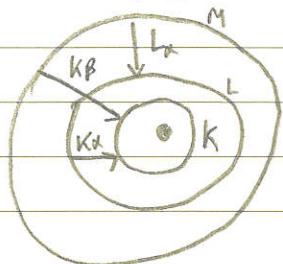
- Lattice spacing  $\approx 1 \text{ \AA} = \lambda$  of X-rays.
- X-rays generated by bombarding a copper target with energetic thermionic electrons.
- The spectrum obtained has two parts: continuous, characteristic



- The cont. spectrum comes from deceleration of electrons, which happens at a different rate for each electron:

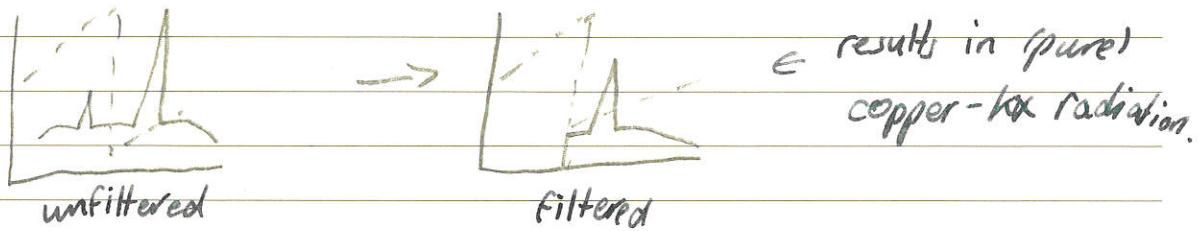
$$\lambda = \frac{hc}{DE}$$

- Characteristic peaks are formed when incident  $e^-$  excites inner shell  $e^-$ . When other  $e^-$  drop into the shell, an X-ray is released.



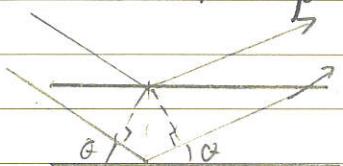
$\rightarrow$  tiny split due to QM

- Transitions from  $L_{II}$  and  $L_{III}$  are equally likely, but  $L_{III}$  has  $4e^-$  vs  $2e^-$  in  $L_{II}$ , so  $K\alpha_1$  intensity double  $K\alpha_2$ .
- $K\beta$  transitions less likely.
- In order to produce X-rays of one wavelength, a Nickel filter can be used, with an absorption edge around  $1.5\text{\AA}$ .



### Diffraction angles

- Assume X-rays reflected by planes of atoms

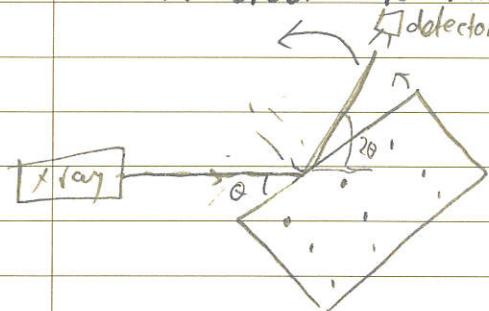


There will be a sharp peak due to constructive interference when  $\Delta = n\lambda$

i.e.  $\Delta = 2d \sin \theta$  (Bragg's law)

- The  $hkl$  reflection is the reflection from  $(hkl)$  planes.
- We will in general be able to see reflections from empty space e.g.  $(200)$  planes between layers  
 $\hookrightarrow$  there are actually 2<sup>nd</sup> order peaks from  $(100)$  planes.

- Interplanar spacing can thus be found by rotating a source and detector to find the angles corresponding to peaks



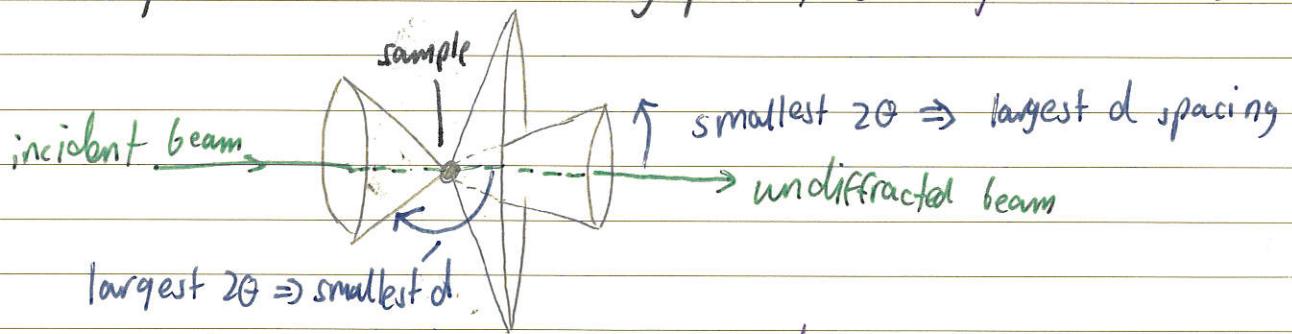
← detector must rotate at twice the rate of the sample.

- Conversely, if we want to calculate the diffraction angles for some planes, we need the spacing:

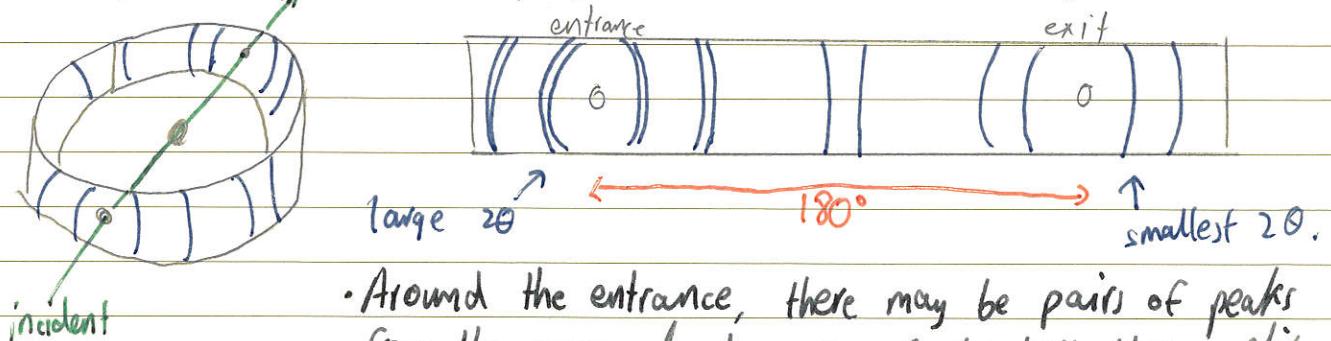
$$\frac{1}{d^2} = \frac{h^2}{a^2} + \frac{k^2}{b^2} + \frac{l^2}{c^2} \text{ for an orthogonal basis set.}$$

## Powder diffraction

- If we use a polycrystalline sample, there will be many orientations of crystals so we will see many peaks, as Debye-Scherrer Cones

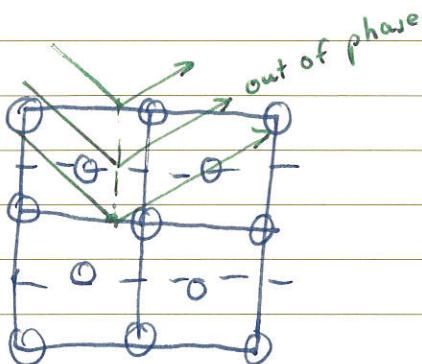


- These angles can be measured with a Debye-Scherrer camera, which wraps a ribbon of photographic film around the sample



- Around the entrance, there may be pairs of peaks from the same d, because of the Kα₁/Kα₂ split.

## Diffraction intensities

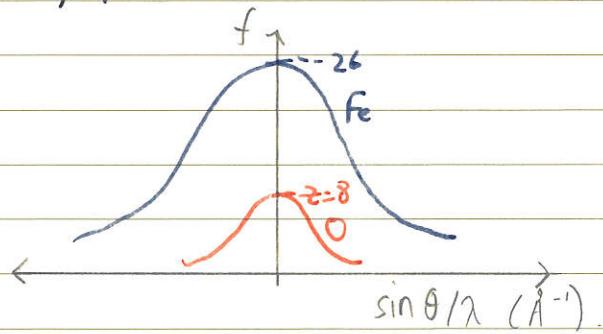
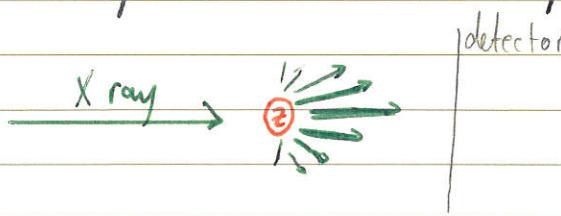


- For a bcc crystal, reflections from the intermediate planes will destructively interfere with the {100} reflection
  - ↳ systematic absence
  - ↳ we only see {200} etc. planes etc.
- However, {110} is present because no intermediate layers have been introduced.
- {111} absent.
- A similar analysis for cubic F shows that only {111} is present.

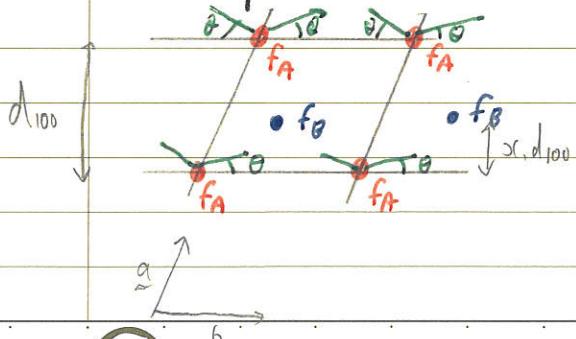
- For any given atom, X-rays are scattered by the electrons. The amount of scattering from an individual atom is described by the scattering factor,  $f$ .

$$f = \frac{\text{atom's overall scattering}}{\text{single } e^- \text{ scattering}}$$

- because there are  $Z$  electrons in our atom, we would expect  $f = Z$ .
- this is only true for constructive interference when the scattering angle is zero. As this angle  $\uparrow$ , there is more destructive interference.



- For multiple atoms we can't just add the scattering factor because of phase



- In the A lattice, X-rays incident at the Bragg angle will be in phase (by definition)
- Consider B atoms some fraction  $x$ , of the distance between the {100} A planes.

$$\text{path diff} = x, \lambda \therefore \phi_{1,x} = 2\pi x,$$

- In general, the phase difference  $\phi_n$  for the  $n$ th atom is:

$$\phi_n = 2\pi(hx_n + ky_n + lz_n)$$

- We define the Structure factor  $F$  as

$$\hat{F} = \frac{\text{crystal's overall scattering}}{\text{single e- scattering}} = \sum f_i \text{ (incl phase)}$$

- We should treat scattering as a complex quantity:

$$\hat{f}_n = f_n e^{i\phi_n} \Rightarrow \hat{F}_{hkl} = \sum_{n=1}^N f_n \exp(2\pi i(hx_n + ky_n + lz_n))$$

- To get the intensity, we take the modulus:

$$I_{hkl} \propto |\hat{F}_{hkl}|^2$$

- Using this analysis, we can reclassify systematic absences.

	Present	Absent
P	all	none
I	$h+k+l$ even	$h+k+l$ odd
F	$h+k+l$ all even/odd	$h+k+l$ mixed.

- This leads to a simplification in the structure factor formula: we can factorise out the contribution from the lattice:

$$P : \hat{F}_{hkl} = (-1) \sum_{\text{motif}} f_n \exp(2\pi i(hx_n + ky_n + lz_n))$$

$$I : \hat{F}_{hkl} = (1 + (-1)^{h+k+l}) \sum_{\text{motif}} (\dots)$$

$$F : \hat{F}_{hkl} = (1 + (-1)^{h+k} + (-1)^{h+l} + (-1)^{k+l}) \sum_{\text{motif}} (\dots)$$

$$\text{i.e. } \hat{F}_{hkl} = \left( \begin{array}{l} \text{sum over lattice} \\ \text{NO Atoms} \end{array} \right) \times \sum_{\text{motif}} \dots$$

- The intensity also scales with multiplicity  $m_{hkl}$ : having more of a particular plane increases intensity.
- Also depends on geometric factors, e.g. a much smaller fraction of the cone will be captured by the camera when  $2\theta = 90^\circ$

- Thus for powder diffraction the intensity is given by:

$$I_{hkl} \propto M_{hkl} |F_{hkl}|^2 g(\theta)$$

↳ in reality, factors like absorption / temp will affect  $I$

↳ any preferred grain orientation can have a significant effect.

### Indexing powder diffraction patterns

- For cubic crystals :  $d_{hkl} = \frac{a}{\sqrt{h^2+k^2+l^2}} = \frac{a}{\sqrt{N}}$

↳ But  $\lambda = 2d_{hkl} \sin\theta \rightarrow \frac{\sin^2\theta}{N} = \frac{\lambda^2}{4a^2} = \text{constant}$

↳ i.e.  $\frac{\sin^2\theta_1}{N_1} = \frac{\sin^2\theta_2}{N_2} = \dots = \frac{\sin^2\theta_n}{N_n} \rightarrow \frac{N_n}{N_1} = \frac{\sin^2\theta_n}{\sin^2\theta_1}$

From this, we use the following procedure:

- Find  $\sin^2\theta/\sin^2\theta$ , for each peak and tabulate
  - Multiply this by an integer if the values aren't already int  
↳ this gives  $N$  for each peak
  - Find 3 numbers whose squares add to  $N$ , giving  $hkl$ .
- These cannot be  $N=7$  because no three squares add to 7.  
↳ P lattices skip  $N=7$  and  $N=15$   
↳ if there appears to be  $N=7$ , multiply everything by 2 so this is  $N=14$  (i.e. 321 reflections), giving an I lattice.
  - This method assumes we know all the peaks, and does not tell us about the motif: this info is in the intensities.

Cubic P : evenly spaced with  $N=7$  and  $N=15$  missing

Cubic I : evenly spaced,  $N=2, 4, 6, 8, \dots$

Cubic F :  $N=3, 4, 8, 11, 12$  (i.e.  $h, k, l$  all odd or all even).

- Some positions have two peaks, e.g.  $N=9$  has 300 and 221.

- There is an upper limit to the number of peaks:

$$N_{\max} = \frac{a^2}{d_{nkl}^2} = \frac{4a^2}{\lambda^2} \quad \text{because } \sin\theta < 1$$

- We will have more accurate results if we use higher  $2\theta$ :

$$d = \frac{\lambda}{2 \sin \theta} \Rightarrow d'(\theta) = -\frac{d}{\tan \theta} \Rightarrow \frac{\delta d}{d} = -\frac{\delta \theta}{\tan \theta}$$

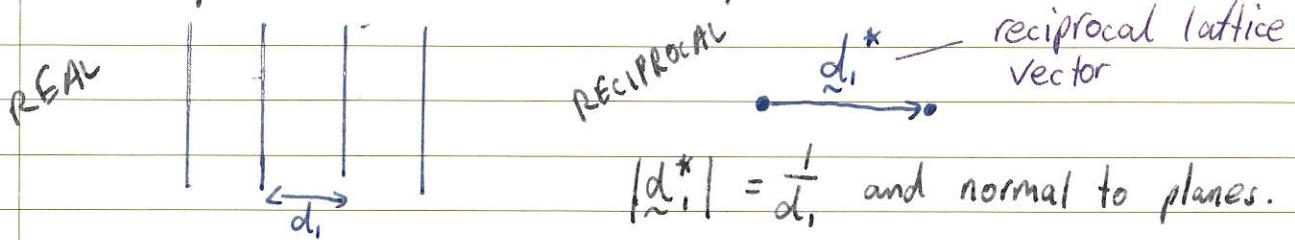
↳ thus higher  $\theta \Rightarrow$  lower  $\delta d/d$

↳ must use radians

↳ eventually, error in  $\lambda$  may become important

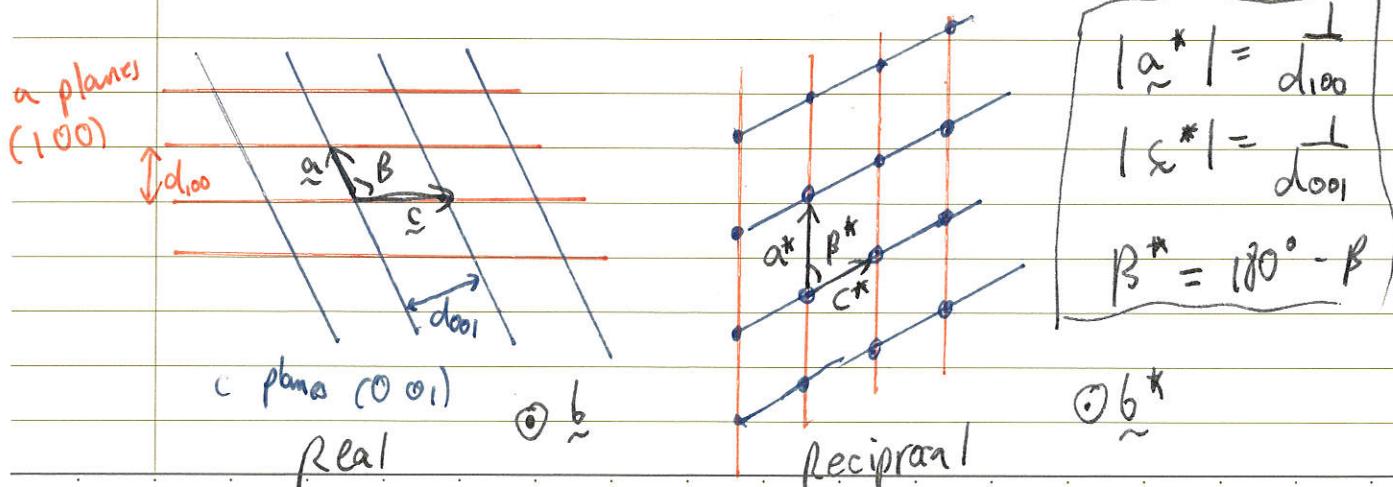
## Reciprocal Lattices

- A reciprocal lattice represents a real lattice in inverse space.
  - ↳ periodic features become points



↳ thus the Reciprocal lattice vector encodes all the info for a set of planes.

- For a primitive monoclinic lattice viewed parallel to [010]:

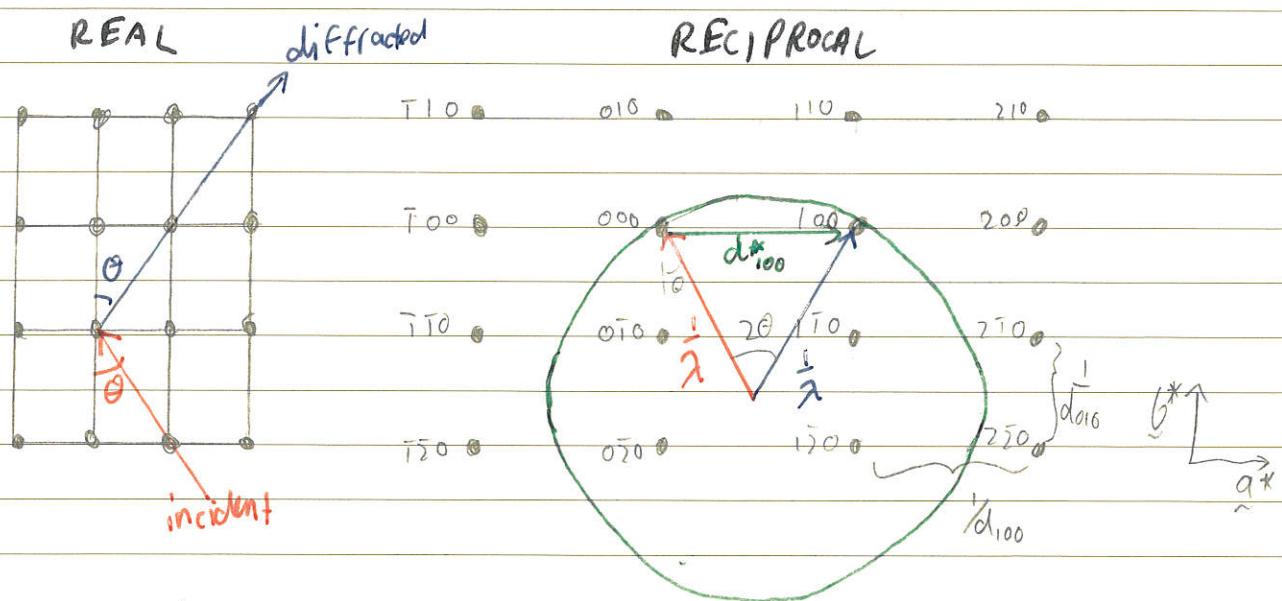


- The reciprocal lattice for a cubic P real lattice is also cubic P.
- However, systematic absences lead to the following result:

$$\begin{array}{ccc} \text{real I lattice} & \longleftrightarrow & \text{reciprocal F lattice} \\ \text{real F lattice} & \longleftrightarrow & \text{reciprocal I lattice} \end{array}$$

## The Ewald sphere

- Draw the reciprocal lattice
- Draw a vector representing an incoming X-ray. It will point to the origin and have length  $\frac{1}{\lambda}$
- Draw a circle/sphere centred on the start of that vector.



- The 100 point lies on the surface of the sphere. We can say.

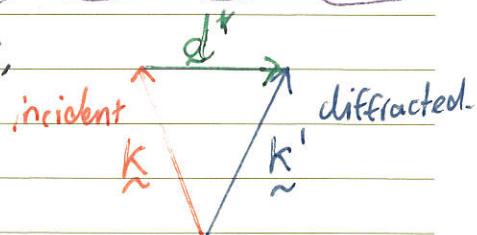
$$\sin \theta = \frac{\frac{1}{2} |d_{100}^*|}{\frac{1}{\lambda}} = \frac{\lambda}{2d_{100}} \Rightarrow \lambda = 2d_{100} \sin \theta$$

- This shows that:

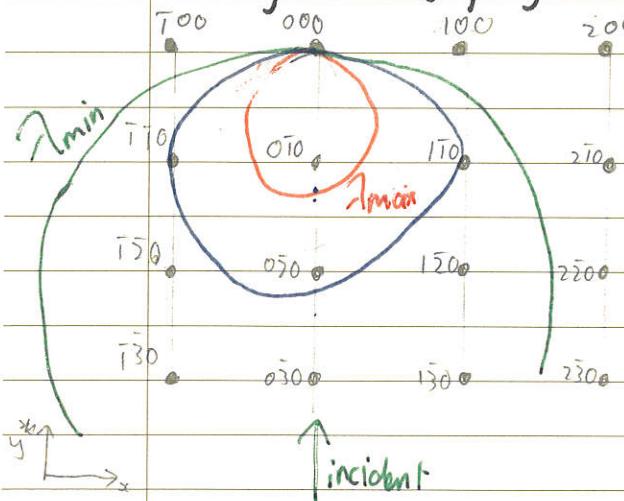
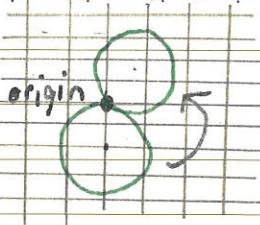
{ Bragg condition satisfied  $\Leftrightarrow$   $d \cdot h \cdot k \cdot l$  on Ewald Sphere }

- The vectors in reciprocal space are wavevectors, satisfying  $\tilde{k}' = \tilde{k} + d^*$

- The Ewald sphere always passes through the origin of reciprocal space



- If we want to measure a particular reflection with  $\lambda$  constant, we imagine rotating the sphere (pinned to the origin) until it intersects
- Alternatively, we can fix the direction and vary  $\lambda$  (e.g. by using 'white' X-rays).



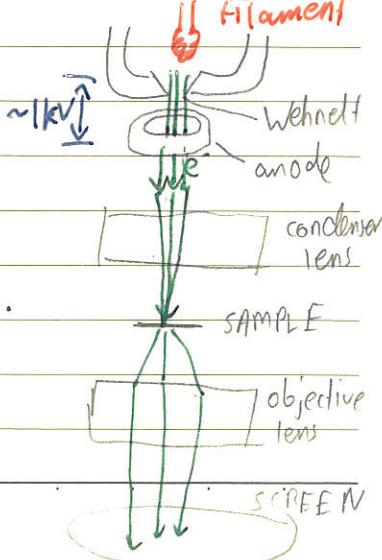
- Within the range of  $\lambda_{\min}$  to  $\lambda_{\max}$ , there will be ~~one~~ spheres intersecting different points, corresponding to different diffractions
- e.g. there is some sphere passing through  $(0\bar{3}0)$ , i.e. diffraction straight back to the source.

## Electron Microscopy

- It is difficult to focus diffracted X-rays into an image. However, with electrons, we can just use electromagnets.
- Additionally, they can have very small wavelengths

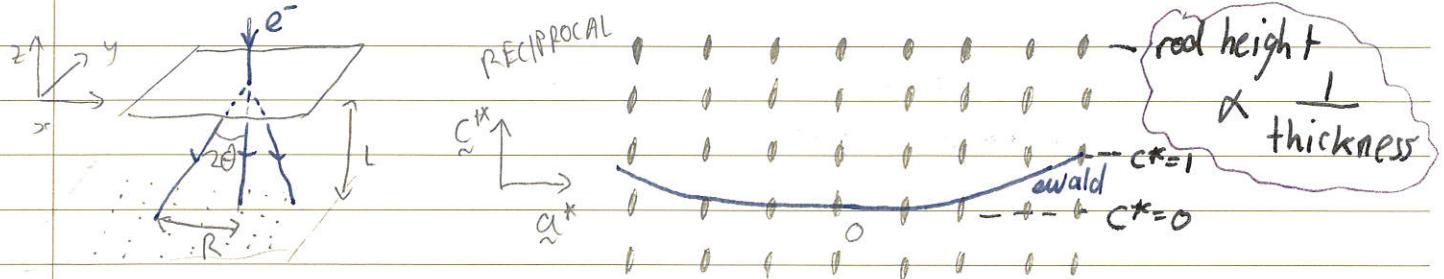
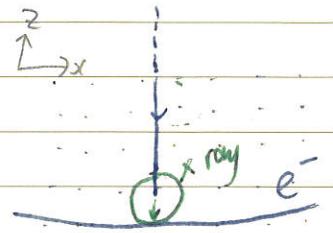
$$\lambda = \frac{h}{p} \text{ and } E = \frac{p^2}{2m} \Rightarrow \left\{ \lambda = \frac{h}{\sqrt{2mE}} \right. \text{ (needs relativistic correction for high } E \text{).}$$

- A transmission electron microscope (TEM) passes electrons through a thin sample.
  - electrons generated by thermionic emission from a hot tungsten filament through a Wehnelt
  - condenser lenses produce a focused beam
  - after scattering, the objective lenses (movable) focus the pattern onto a screen (e.g. CC or film).
    - ↳ because they are electromagnetic lenses, the focal length can be adjusted.

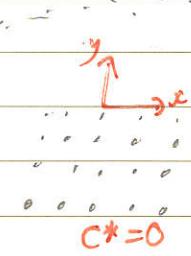


## Electron diffraction patterns

- The Ewald spheres will be much larger than in X-ray diffraction because  $\lambda$  much smaller.
- Because we are using a thin film, the reciprocal lattice points become rods in the direction of the normal (i.e z).



- The diffraction pattern will then be xy cross sections
- Because the Ewald sphere intersects many points in the  $c^*=0$  layer, we get many spots that can be used to find the lattice parameters
- There are some  $c^*=1$  reflections too.



- From the geometry of the defector setup:

$$\hookrightarrow \tan 2\theta = R/L \Rightarrow 2\theta = R/L \text{ for small } \theta.$$

$$\hookrightarrow \sin \theta \approx \theta \therefore \text{Bragg's law: } \lambda = 2d_{hkl} \theta$$

$$\therefore d_{hkl} = \frac{\lambda L}{R} \quad \text{with } \lambda L = \text{camera constant}$$

## Electron microscope imaging

- Using the objective aperture, whose width and position can be varied, we can form an image from specific diffraction spots
- ↪ a bright field image contains the central spot and illuminates many features
- ↪ dark field images include the electrons that have interacted strongly, highlighting imperfections



- To get the highest resolution image, multiple spots should be used

### Scanning electron microscopes

- Unlike the TEM, the SEM does not use diffraction.
- Focuses on inelastic scattering, leading to:
  - heat (ignored)
  - secondary electrons emitted by excited atoms
  - backscattered electrons from elastic collisions
  - X-rays / light from excited electrons dropping to ground.
- Secondary electrons are used to image the surface
- Backscattered electrons can give info about chemical composition.

